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SERIAL NUMBER 10/519,449	FILING or 371(c) DATE 08/25/2005 RULE	CLASS 438	GROUP ART UNIT 1795	ATTORNEY DOCKET NO. SON-2782		
APPLICANTS Minoru Sugawara, Kanagawa, JAPAN; ** CONTINUING DATA ***** This application is a 371 of PCT/JP03/08377 07/01/2003 ** FOREIGN APPLICATIONS ***** JAPAN 2002-193168 07/02/2002 JAPAN 2002-200777 07/10/2002 ** IF REQUIRED, FOREIGN FILING LICENSE GRANTED **						
Foreign Priority claimed <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No 35 USC 119(a-d) conditions met <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No Verified and Acknowledged <u>/RASHID A ALAM/</u> Examiner's Signature		<input type="checkbox"/> Met after Allowance Initials	STATE OR COUNTRY JAPAN	SHEETS DRAWINGS 48	TOTAL CLAIMS 20	INDEPENDENT CLAIMS 3
ADDRESS RADER FISHMAN & GRAUER PLLC LION BUILDING 1233 20TH STREET N.W., SUITE 501 WASHINGTON, DC 20036 UNITED STATES						
TITLE Phase shift mask fabrication method thereof and fabrication method of semiconductor apparatus						
FILING FEE RECEIVED 1030	FEES: Authority has been given in Paper No. _____ to charge/credit DEPOSIT ACCOUNT No. _____ for following:		<input type="checkbox"/> All Fees <input type="checkbox"/> 1.16 Fees (Filing) <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) <input type="checkbox"/> 1.18 Fees (Issue) <input type="checkbox"/> Other _____ <input type="checkbox"/> Credit			